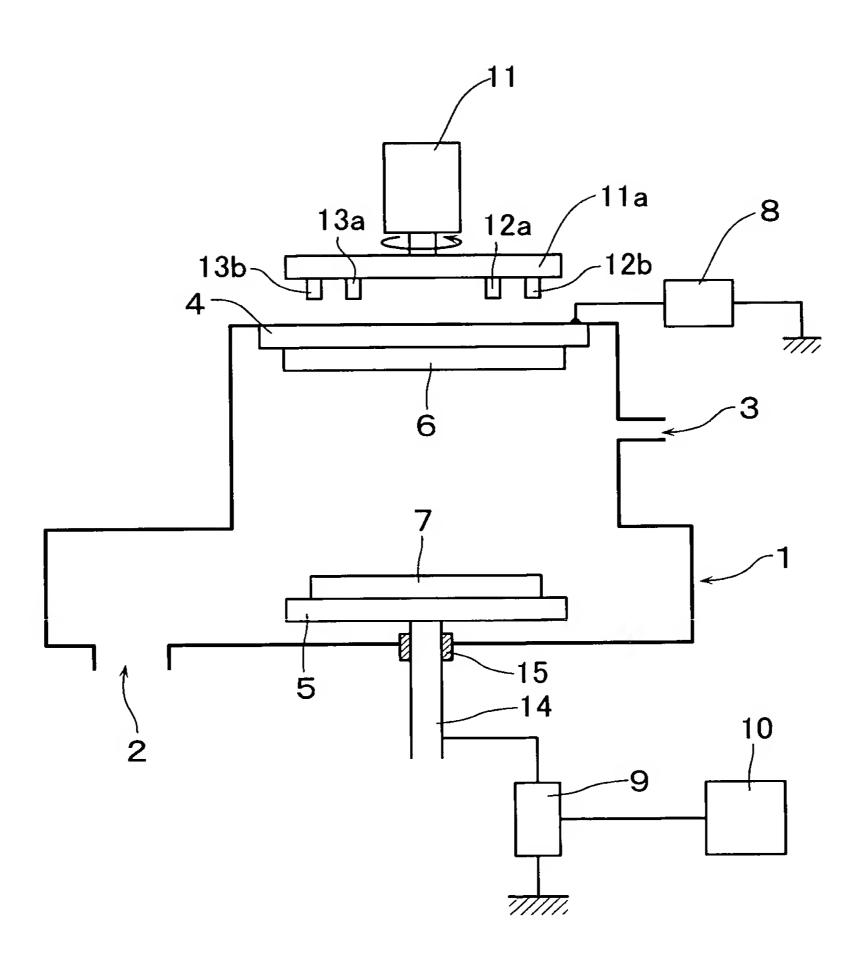
Title: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING FILM FORMING APPARATUS Inventor: Myounggoo LEE et al. Docket Number: 101136-00095

FIG.1



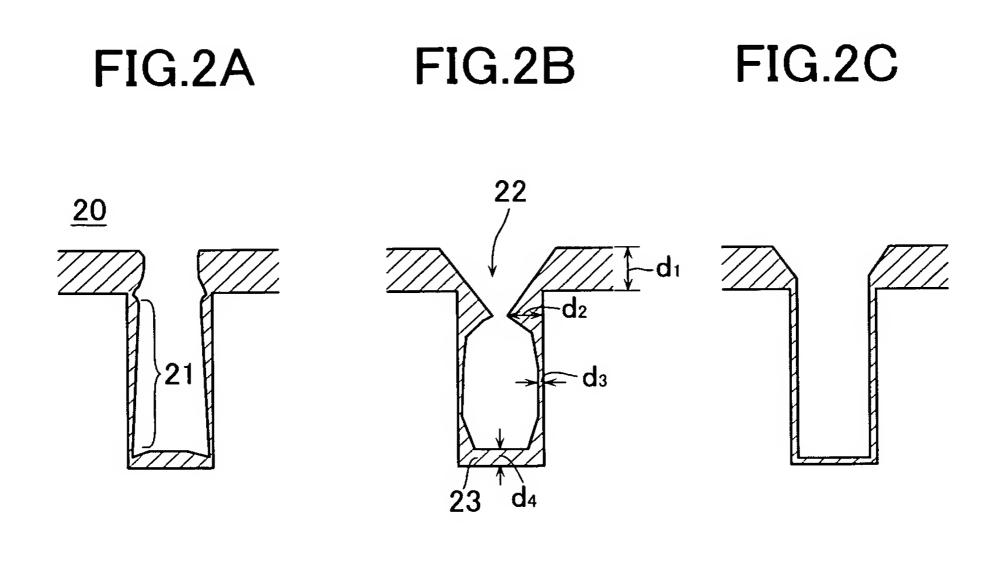


FIG.3

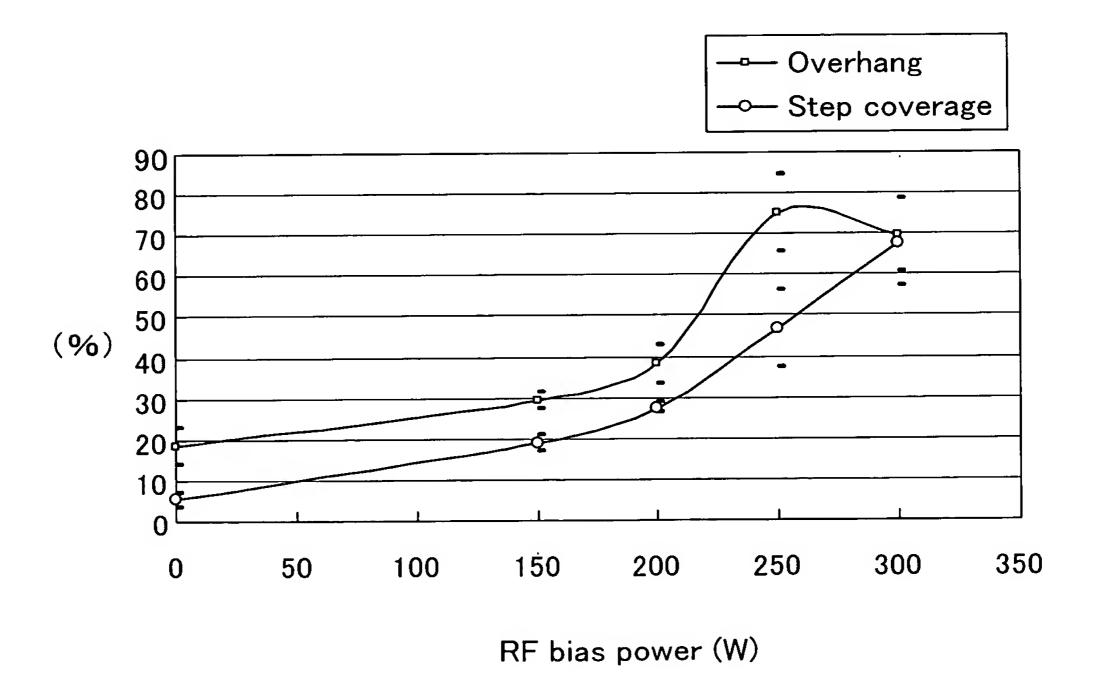
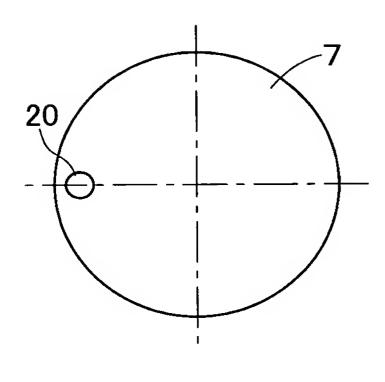


FIG.4A

FIG.4B



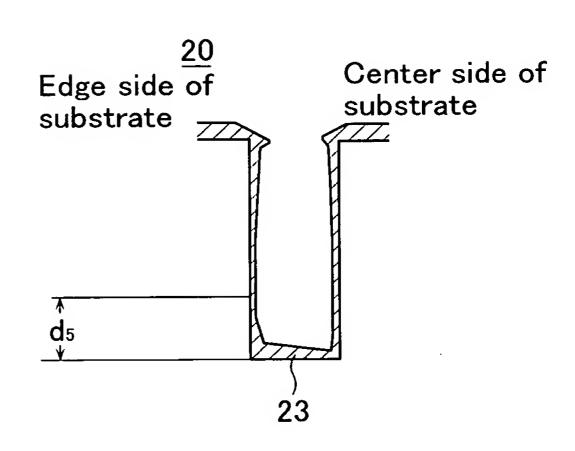


FIG.4C

Height location at minimum side coverage (ds/nm)

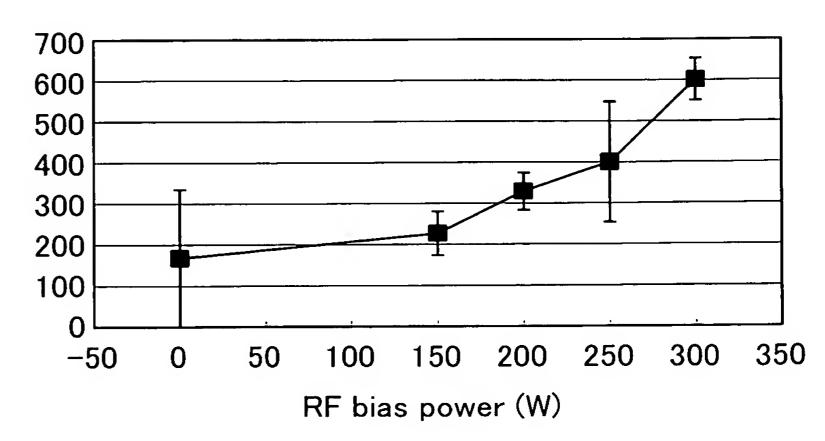


FIG.5A

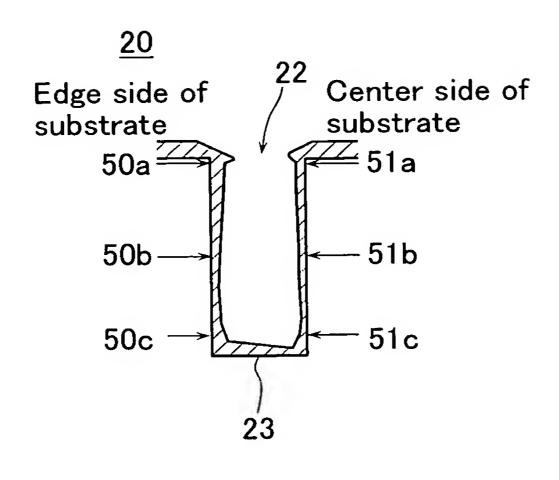
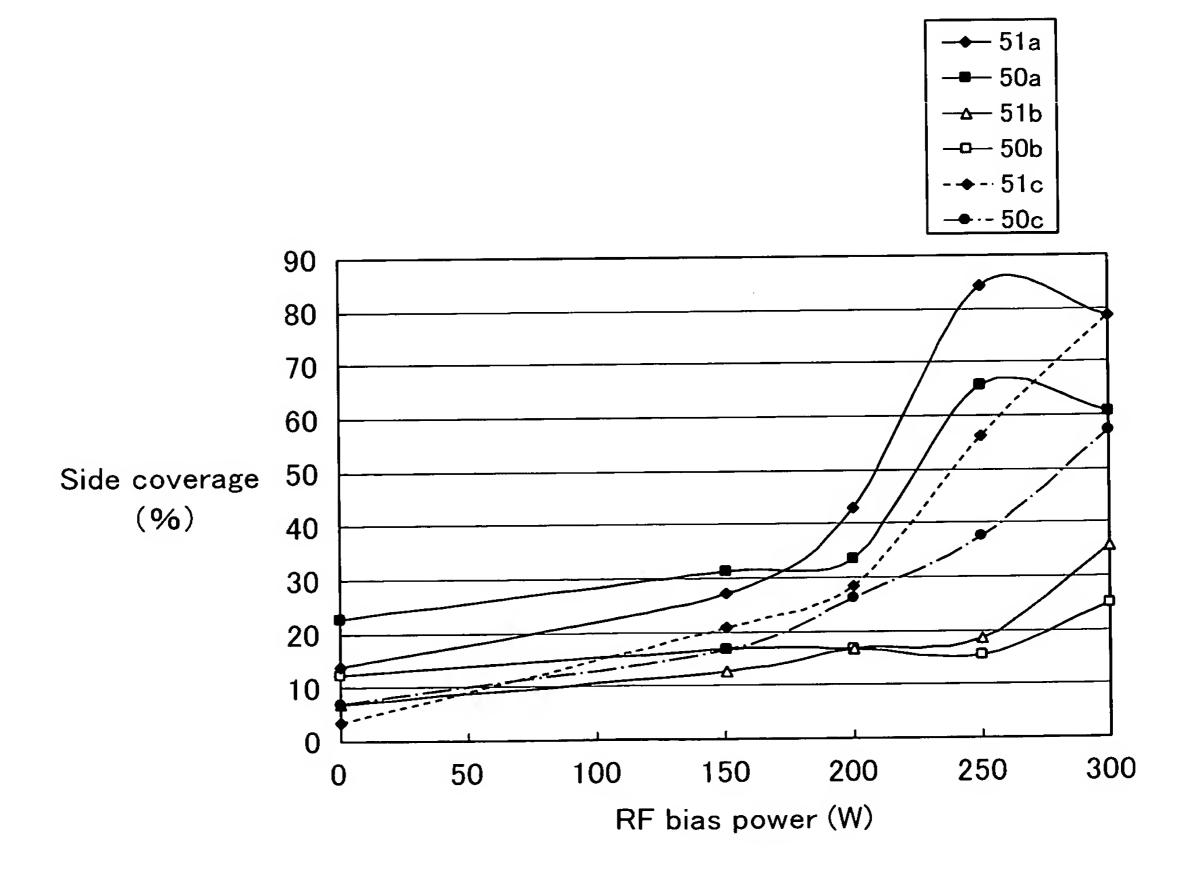


FIG.5B



PROCESS AND BIAS SPUTTERING FILM FORMING APPARATUS Inventor: Myounggoo LEE et al. Docket Number: 101136-00095

FIG.6A

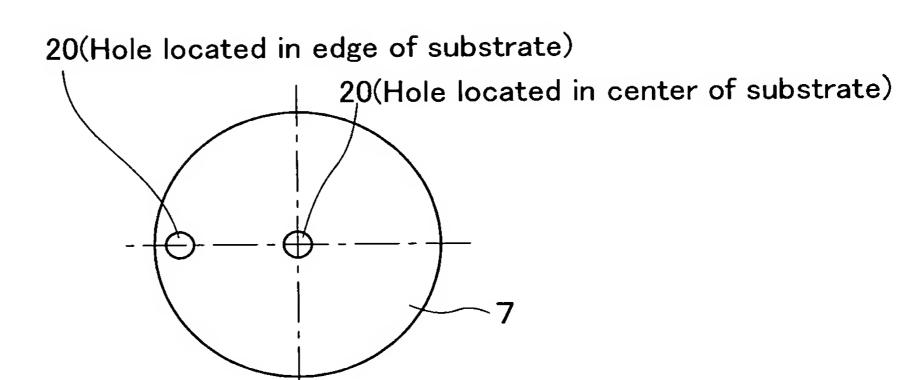


FIG.6B

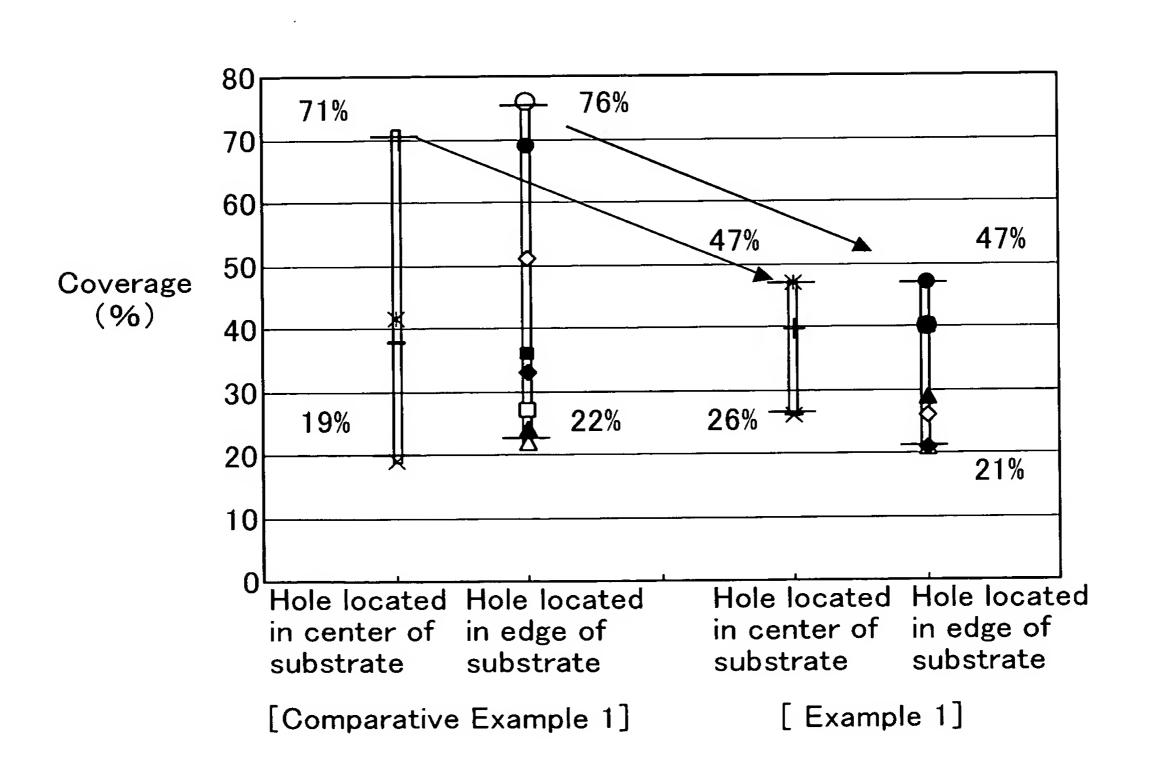


FIG.7

